



Docket No. 740819-548

RESPONSE UNDER 37 CFR 1.116 – EXPEDITED
PROCEDURE – EXAMINING GROUP 2800

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Mitsuru TANABE

Serial No.: 09/838,214

Filed: April 20, 2001

For: MICROSTRIP LINE, METHOD FOR
FABRICATING THE SAME,
INDUCTOR ELEMENT, AND RF
SEMICONDUCTOR DEVICE

)

) Group Art Unit: 2817

) Examiner: Benny T. LEE

) Confirmation No.: 9367

) Date: September 18, 2003

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CERTIFICATE OF MAILING
[37 CFR 1.8(a)]

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Name:

Sharon L. Tabor

*Approved for entry
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AMENDMENT AFTER FINAL

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed June 18, 2003, please amend the above
identified application as follows.

09/26/2003 HBIZU:ES 00000040 09830214

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